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Application No.	Applicant(s)	
10/622.044	KANO ET AL.	
Examiner	Art Unit	
Richard H. Kim	2871	,
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	Richard H. Kim  Pears on the cover sheet with S (OR REMAINS) CLOSED in 5) or other appropriate communication is said and MPEP 1308.  Under 35 U.S.C. § 119(a)-(d) of the been received in Application documents have been received documents have been received in Application.  E" of this communication to file NMENT of this application.  Demitted. Note the attached EXA ives reason(s) why the oath of the submitted.  Person's Patent Drawing Review er's Amendment / Comment on the header according to 37 CF cosit of BIOLOGICAL MATER TOR THE DEPOSIT OF BIOLOGICAL MATER TORS THE	Examiner   Art Unit   2871

## **DETAILED ACTION**

## Allowable Subject Matter

- 1. Claims 21-25, 27 and 29-34 allowed.
- 2. The following is an examiner's statement of reasons for allowance: The prior art of record, taken alone or in combination, fails to teach or disclose in light of the specifications, an active matrix display wherein each pixel electrode and switching element is connected through multiple contact holes; wherein the contact holes are masked in a plan view.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

## Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Richard H. Kim whose telephone number is (571)272-2294. The examiner can normally be reached on 9:00-6:30 M-F.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on (571)272-1787. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Application/Control Number: 10/622,044

Art Unit: 2871

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Richard H Kim Examiner Art Unit 2871

**RHK** 

Supervisory Patent Examiner
Technology Center 2800